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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Akinori KOUKITSU et al.

Application No.: 10/509,177

Filed: September 27, 2004 Docket No.: 121213

For: VAPOR PHASE GROWTH METHOD FOR AL-CONTAINING III-V GROUP

COMPOUND SEMICONDUCTOR, AND METHOD AND DEVICE FOR PRODUCING

AL-CONTAINING III-V GROUP COMPOUND SEMICONDUCTOR

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. An English language Abstract of one or more non-English language reference is attached hereto. See References 1-4.

3. A computer-generated English language translation of one or more Japanese Patent Publication cited herein has been obtained from the website of the Japanese Patent Office ([http://www.jpo.go.jp]), and is attached, but has not been reviewed for accuracy.

See References 1 and 3-4.

Respectfully submitted,

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JAO:JSA/ldg

Date: August 15, 2006

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400 DEPOSIT ACCOUNT USE
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		υ	.S. PATEN	T DOCUM	MENTS				
Examiner Initials	Cite No.	Document Number	Date		Name				
FOREIGN PATENT DOCUMENTS									
Examiner Initials	Cite No.	Document Number	Da	ite	Country		With English Abstract	With English Translation	
	1	JP-A-2000-091234	03/31/20	00	Japan		х	х	
	2	JP-A-03-218917	09/26/19	91	Japan		х		
	3	JP-A-05-327398	12/10/19	93	Japan		Х	х	
	4	JP-A-2001-181097	07/03/20	01	Japan		х	х	
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